

Docket No. 294550US0PCT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Jean DIJON, et al.

SERIAL NO: 10/588,703

GAU:

FILED: August 8, 2006

EXAMINER:

FOR: METHOD OF PRODUCING A LAYER OF MATERIAL ON A SUPPORT

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Applicant(s) wish to disclose the following information.

REFERENCES

- ☒ The applicant(s) wish to make of record the references listed on the attached form PTO-1449. Copies of the listed references are attached, where required, as are either statements of relevancy or any readily available English translations of pertinent portions of any non-English language references.
- ☐ A check or credit card payment form is attached in the amount required under 37 CFR §1.17(p).

RELATED CASES

- ☐ Attached is a list of applicant's pending application(s), published application(s) or issued patent(s) which may be related to the present application. In accordance with the waiver of 37 CFR 1.98 dated September 21, 2004, copies of the cited pending applications are not provided. Cited published and/or issued patents, if any, are listed on the attached PTO form 1449.
- ☐ A check or credit card payment form is attached in the amount required under 37 CFR §1.17(p).

CERTIFICATION

- ☐ Each item of information contained in this information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.
- ☐ No item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the undersigned, having made reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this statement.

DEPOSIT ACCOUNT

- ☒ Please charge any additional fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit account number 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.

Norman F. Oblon

Registration No. 24,618

Customer Number

22850

Tel. (703) 413-3000
Fax. (703) 413-2220
(OSMMN 05/03)

Surinder Sachar

Registration No. 34,423



U.S. PCT Application Serial No: 10/588,703

Filed: August 8, 2006

Jean DIJON, et al.

Docket No. 294550US0PCT

STATEMENT OF RELEVANCY

- 1) References AA - AB, AO - AP and AV - AW have been cited in the International Search Report. A copy of these references is being submitted herewith.
- 2) References have been cited in the corresponding Search Report. A copy of these references is being submitted herewith.
- 3) References AX - AZ are discussed in the specification. A copy of these references is being submitted herewith.
- 4) References are additional prior art known to Applicant. A copy of these references is being submitted herewith.



Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 294550US0PCT		SERIAL NO. 10/588,703	
LIST OF REFERENCES CITED BY APPLICANT				APPLICANT Jean DIJON, et al.			
				FILING DATE August 8, 2006		GROUP	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA	2003 0234417	12-25-03	RAAIJMAKERS, Ivo et al.			
	AB	5 084 144	01-28-92	REDDY, N. R. K. et al.			
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES NO		
	AO	03 027011	04-03-03	WO			NO
	AP	96 22841	08-01-96	WO			NO
	AQ						
	AR						
	AS						
	AT						
	AU						
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)							
	AV	YUDASAKA, Masako et al., "Specific Conditions for Ni Catalyzed Carbon Nanotube Growth by Chemical Vapor Deposition", Applied Physics Letters, Vol. 67, No. 17, pgs. 2477-2479, 1995.					
	AW	COTTEL, C. M. et al., "Microstructural Development of Thin Films Grown by Pulsed Laser Deposition", Materials Science and Engineering B, Vol. 32, No. 3, pgs. 221-230, 1995.					
	AX	SIEGAL, M. P. et al., "Precise Control of Multiwall Carbon Nanotube Diameters Using Thermal Chemical Vapor Deposition", Applied Physics Letters, Vol. 80, No. 12, pgs. 2171-2173, 2002.					
	AY	GAO, J. S. et al., "Plasma Breaking of Thin Films into Nano-Sized Catalysts for Carbon Nanotube Synthesis", Materials Science and Engineering A, Vol. 352, pgs. 308-313, 2003.					
	AZ	CHOI, Jong Hyung et al., "Density Control of Carbon Nanotubes Using NH ₃ Plasma Treatment of Ni Catalyst Layer", Thin Solid Films, Vol. 435, pgs. 318-323, 2003.				<input type="checkbox"/> Additional References sheet(s) attached	
Examiner					Date Considered		
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							